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Paper No. 20040428

Director's Office  
Group 3700

*In re* Application of SHIMIZU ET AL.

Appl. No.: 10/085,092

Filed: March 01, 2002

For: **HEAT TREATMENT APPARATUS USING A  
LAMP FOR RAPIDLY AND UNIFORMLY  
HEATING A WAFER**

**WITHDRAWAL FROM  
ISSUE**

37 CFR 1.313

The purpose of this communication is to inform you that the above identified application is being withdrawn from issue pursuant to 37 CFR 1.313.

The application is being withdrawn to permit reopening of prosecution. The reasons therefor will be communicated to you by the examiner.

U.S. Patent and Trademark Office records reveal that the issue fee and the publication fee have not been paid. If the issue fee and the publication fee have been submitted, the applicant may request a refund, or may request that the fee be credited to a deposit account. However, applicant may wait until the application is either again found allowable or held abandoned. If the application is allowed, upon receipt of a new Notice of Allowance and Issue and Publication Fee Due, applicant may request that the previously submitted issue fee and publication fee be applied toward payment of the issue fee and publication fee in the amount identified on the new Notice of Allowance and Issue and Publication Fee Due. If the application is abandoned, applicant may request either a refund or a credit to a specified Deposit Account.

The application is being forwarded to the examiner for action.

Richard Bertsch

Director

Patent Examining Technology Center 3700

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